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PATENT
Atty. Docket No. SNS-006CP1
(7268/10)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANTS: Shih et al.
SERIAL NO.: 09/347,637 **GROUP NO.:** 2671
FILING DATE: July 6, 1999 **EXAMINER:** E. L. Santiago
TITLE: SYSTEMS AND METHODS FOR SCULPTING VIRTUAL
OBJECTS IN A HAPTIC VIRTUAL REALITY
ENVIRONMENT

Via Facsimile to (703) 746-5845

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AMENDMENT AND RESPONSE

This paper is responsive to the Final Office action mailed from the United States Patent Office on June 4, 2002, in the above-identified patent application. Applicants respectfully request that the amendments and remarks that follow be considered, and that the rejections made in the Final Office action be withdrawn. Applicants believe that no fee is due, but if any fee is due, the Commissioner is hereby authorized to charge any such fee to Deposit Account No. 20-0531.

In accordance with 37 C.F.R. 1.121(c), Applicants submit herewith separate sheets presenting each amended claim in marked up form showing all the changes relative to the previous version of the claim, as well as a clean version of all claims pending in the application.

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